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Jacqueline J. Garner

Texas Instruments incorporated

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Lu et al.

Art Unit:

2826

Serial No.:

10/722,013

Examiner:

Erdem, F.

Filing Date:

11/25/2003

Docket No.:

TI-35669

Customer No.:

23494

Conf. No.:

6979

Title: A CAPACITOR FORMED ON A RECRYSTALLIZED POLYSILICON LAYER

AND A METHOD OF MANUFACTURE THEREFOR

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on the date shown below:

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April 3, 2006

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FACSIMILE COVER SHEET

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Texas Instruments Incorporated PO Box 655474, M/S 3999 Dallas, TX 75074